



CFM AF

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 10/574,113                      Group Art Unit: 1711  
Filing Date: December 29, 2006                      Examiner: Jason Mark Heckert  
Applicant: Joung-Hyeon LIM et al.  
Title: FACILITY WITH MULTI-STORIED PROCESS CHAMBER FOR  
CLEANING SUBSTRATES AND METHOD FOR CLEANING  
SUBSTRATES USING THE FACILITY  
Attorney Docket: 8947NS-000177/US

Customer Service Window  
Randolph Building  
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November 16, 2010

Do Not Enter  
/JMH/

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Sir:

In response to the Office Action mailed September 16, 2010, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Claims** begin on page 2 of this Amendment.

**Remarks** begin on page 13 of this Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
<b>Total</b>	39	-	40	=	0
<b>Independent</b>	2	-	3	=	0